

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|--------|--|---|------------------|---------|------------------|
| L1 | 0 | "6080529".pn. and (adhesive near gas) | US-PGPUB; USPAT | OR | OFF | 2006/10/14 12:31 |
| L2 | 3 | ((("6080529") or ("6177353") or ("6660647")).PN. | US-PGPUB; USPAT | OR | OFF | 2006/10/14 13:41 |
| L3 | 175574 | (radio near frequency or "rf") same (multiple or plural\$3 or control\$3 or reduc\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:49 |
| L4 | 991 | 3 same (plasma same (periodic near "on" or "off")) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:50 |
| L5 | 328 | 4 and (fluorine or halogen and oxygen) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:45 |
| L6 | 50 | 5 and @pd<"19980312" | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:50 |
| L7 | 84172 | (radio near frequency or "rf" near bias near voltage) same (multiple or plural\$3 or control\$3 or reduc\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:52 |
| L8 | 172 | 7 same (plasma same (periodic near "on" or "off")) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:50 |
| L9 | 42 | 8 and @pd<"19980312" | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:52 |
| L10 | 305 | ((radio near frequency or "rf") near bias near voltage) same (multiple or plural\$3 or control\$3 or reduc\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:52 |

EAST Search History

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|-----|----|--|---|----|-----|------------------|
| L11 | 32 | 10 and @pd<"19980312" | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/10/14 13:55 |
| L12 | 54 | ono-tetsuo.in. | US-PGPUB; USPAT | OR | OFF | 2006/10/14 13:57 |
| L13 | 6 | 12 and ((radio near frequency or "rf") near bias near voltage) | US-PGPUB; USPAT | OR | OFF | 2006/10/14 14:00 |
| L14 | 0 | (("n" near type near polycrystal\$4) same etch\$3) same (control\$4 same "rf" near bias near voltage) | US-PGPUB; USPAT | OR | OFF | 2006/10/14 14:01 |